The Arrival of the Applied Materials Epitaxial Silicon Germanium Deposition System

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Photos: M. Leullier
AMAT delivers!
All the way from Texas... to Berkeley.
We have the capacity... but not the angle.
Lesson learned - Flat bed preferred.
Unloading the main frame.
Controller and support equipment
All tilt and shock sensors - OK.
Ready for breakdown.
Main frame sited in the new lab.
The fight for piping clearance pays off.
The deposition chamber unwrapped.
The controller rack in place.